

## INTERNATIONAL SEARCH REPORT

International application No.

PCT/JP2004/018981

## A. CLASSIFICATION OF SUBJECT MATTER

Int.Cl<sup>7</sup> H01L21/02, H01L27/12, H01L21/336, H01L21/762, H01L29/786

According to International Patent Classification (IPC) or to both national classification and IPC

## B. FIELDS SEARCHED

Minimum documentation searched (classification system followed by classification symbols)

Int.Cl<sup>7</sup> H01L21/02, H01L27/12, H01L21/336, H01L21/762, H01L29/786

Documentation searched other than minimum documentation to the extent that such documents are included in the fields searched

Japanese Utility Model Gazette 1922-1996, Japanese Publication of Unexamined Utility Model Applications 1971-2005, Japanese Registered Utility Model Gazette 1994-2005, Japanese Gazette Containing the Utility Model 1996-2005

Electronic data base consulted during the international search (name of data base and, where practicable, search terms used)

IEEE Xplore, Web of Science

## C. DOCUMENTS CONSIDERED TO BE RELEVANT

Category*	Citation of document, with indication, where appropriate, of the relevant passages	Relevant to claim No.
X	JP 2003-78118 A (CANON KABUSIKI KAISHA) 2003.03.14, whole document, Figure 1-6, (Family: none)	1-8, 10-14, 16, 19, 20
A	Michael I. Current, et al., 'Atomic-layer Cleaving with SiGe Strain Layers for Fabrication on Si and Ge-rich SOI Device Layers', IEEE International SOI Conference, October 2001, pp.11-12	9, 15, 17, 18
A	JP 2003-78140 A (Mitsubishi Material Silicon Corporation) 2003.03.14, whole document, Figure 1-6, (Family: none)	1-20

☐ Further documents are listed in the continuation of Box C.☐ See patent family annex.

\* Special categories of cited documents:

"A" document defining the general state of the art which is not considered to be of particular relevance

"E" earlier application or patent but published on or after the international filing date

"L" document which may throw doubts on priority claim(s) or which is cited to establish the publication date of another citation or other special reason (as specified)

"O" document referring to an oral disclosure, use, exhibition or other means

"P" document published prior to the international filing date but later than the priority date claimed

"T" later document published after the international filing date or priority date and not in conflict with the application but cited to understand the principle or theory underlying the invention

"X" document of particular relevance; the claimed invention cannot be considered novel or cannot be considered to involve an inventive step when the document is taken alone

"Y" document of particular relevance; the claimed invention cannot be considered to involve an inventive step when the document is combined with one or more other such documents, such combination being obvious to a person skilled in the art

"&amp;" document member of the same patent family

Date of the actual completion of the international search

11.03.2005

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29.03.2005

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